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Materials Characterization of Dissolved Chalcogenide Spin Coated Thin Films

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7 1

Materials Characterization of Dissolved Chalcogenide Spin Coated Thin Films

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Introduction

Additive manufacturing technology or 3D printing is a process that creates a physical object from a digital design. Our main goal is to fabricate a space grade radiation sensing device using additive manufacturing technology. Ink development is the first phase of this process. We have developed both nano-particle and dissolved ink [1]. In this presentation we demonstrate the dissolved ink making process of Se based chalcogenide glass and report material characterization of dissolved Chalcogenide Spin Coated Thin Films using tensiometer, XRD, SEM, EDS.

Chalcogenide Glass & Its Applications

Chalcogenide glasses have a wide range of applications because of its significant unique physical and chemical properties including absorption coefficient, nonlinear optical susceptibility, resistance, crystal structure and morphology, wide IR transmission window or high values of refractive index [2].

> Remote Chemical Sensing



Experimental Method

Glass synthesis Compositio Calculation ill quart Weight 5f according to atomic Mass seal it tube furnace

Dissolution based chalcogenide glass (Ge_xSe_{100-x}) ink formulation

Crushed into Chalcogenide powder using Mix the powder with basic Ultra sonicate the Vacuum filtration of th Ink is ready for mortar and glass solvent at 40°C with pestle magnetic stirrer

· Contact angle of dissolution based chalcogenide glass ink



Objective

- · To develop dissolution based Ge-Se chalcogenide glasses ink for fabricating radiation sensor using additive manufacturing technology.
- To apply Ag diffusion technique under radiation source to monitor radiation dose.
- · Using Additive manufacturing technology to avoid complexity of conventional deposition techniques and high cost.

Fig. 1 Contact angle of Dissolution based chalcogenide glass ink (top) Ge40Se60, (bottom) Ge30Se70 in oxidized films.

Thin film preparation & sintering process





Characterization



Fig. 2 (Left) EDS spectra of Ge40Se60 (right) EDS spectra of Ge30Se70 spin coated thin film shows that the compositional variance is within $\pm 1\%$ of the bulk . (Right)



Fig. 3 SEM micrograph of spin coated Ge₄₀Se₆₀ (left) and Ge₃₀Se₇₀ (right).



Fig. 4 (Left) XRD of spin coated thin Ge-Se film (left Ge40Se60) and (right Ge₃₀Se₇₀), DB no: 00-032-0410,01-083-1832, shows that the films are amorphous in nature.

Conclusion

Chalcogenide glasses are soluble in basic solutions and this property has been used for ink formation through dissolution. Before starting printing we did material and ink characterization. We measured 10° to 14° of contact angle which indicated that it has good adhesion with substrate. We also checked atomic composition of spin coated films using EDS and confirmed amorphous nature of spin coated films using XRD. In future, we will use this dissolution based ink for fabricating space grade radiation sensor using additive manufacturing technology on flexible substrate.

Reference

- 1. A Ahmed Simon et al., M & M (2019) in press.
- 2. S. M. R. Ullah et al., M & M (2019) in press.
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